194679US0DL

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

KOUJI HAMANO, ÆT AL

: ATTN: APPLICATIONS BRANCH

FILED: HEREWITH

FOR: LITHIUM ION SECONDARY BATTERY AND METHOD OF

FABRICATING THEREOF

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER OF PATENTS WASHINGTON, D.C. 20231

SIR:

Prior to examination on the merits, please amend the above-identified application as

follows:

Please cancel claims 1-7 without prejudice.

REMARKS

Claims 1-7 have been canceled, leaving claims 8-13 for examination.

The application is ripe for examination on the merits. An early examination is respectfully solicited.

Respectfully submitted,

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HAP:bj

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